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JUL 27 2007
PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814
Examiner: Long PHAM

In Re PATENT APPLICATION Of:

Applicants : Jiro MATSUMOTO

Appln. No. : 10/727,662

Filed : December 5, 2003

For : SEALING APPARATUS FOR SEMICONDUCTOR WAFER, MOLD OF SEALING APPARATUS AND SEMICONDUCTOR WAFER

AMENDMENT AFTER FINAL ACTION

Attorney Ref.: F00ED0150-DIV

July 27, 2007

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Final Office Action mailed February 27, 2007, which has been extended to expire on May 27, 2004 by Petition for two-month Extension of Time filed herewith, please amend the above-identified application as follows: